Amendments to the Claims:

The following listing of claims will replace all prior versions, and listings, of claims in the application:

1. (Currently Amended) A droplet discharge method for ~~discharging a liquid material from a discharge device and arranging the~~disposing liquid material in a specified quantity on a substrate by discharging the liquid material from a discharge device,

the discharge device comprising a nozzle for discharging the liquid material in droplets, and

the droplet discharge method comprising the steps of:

cleaning the nozzle ~~using~~ by discharging the liquid material from the nozzle; and

~~arranging at least a part of~~disposing the liquid material ~~used for cleaning~~ on the substrate by discharging the liquid material from the nozzle,

wherein the liquid material used in the cleaning step is disposed on the substrate, and the quantity of the liquid material disposed on the substrate in the step of cleaning and the quantity of the liquid material disposed on the substrate in the step of disposing constitute the specified quantity.

2. (Original) A droplet discharge method according to claim 1, wherein the liquid material is warmed to room temperature or higher.

3. (Currently Amended) A manufacturing method for a liquid crystal device ~~involving discharging a liquid crystal from a discharge device, and arranging the~~for a liquid crystal in a specified quantity on a first substrate by discharging the liquid crystal from a discharge device,

the discharge device comprising a nozzle for discharging the liquid crystal in droplets, and

the manufacturing method comprising the steps of:

cleaning the nozzle ~~using~~ by discharging the liquid crystal from the nozzle; and

~~arranging at least a part of~~disposing the liquid crystal ~~used for cleaning~~ on the first substrate by discharging the liquid crystal from the nozzle,

wherein the liquid crystal used in the cleaning step is disposed on the first substrate, and the quantity of the liquid crystal disposed on the first substrate in the step of cleaning and the quantity of the liquid crystal disposed on the first substrate in the step of disposing constitute the specified quantity.

4. (Original) A manufacturing method for a liquid crystal device according to claim 3,

wherein a sealing material for adhering the first substrate to a second substrate is arranged on the first substrate, and

a specified quantity of liquid crystal is arranged on the first substrate, away from the sealing material.

5. (Original) A manufacturing method for a liquid crystal device according to claim 4, wherein after the first substrate and the second substrate are adhered to each other via said sealing material, the liquid crystal is spread over a whole space between the first substrate and the second substrate.

6. (Original) A manufacturing method for a liquid crystal device involving discharging a liquid material from a discharge device to form a predetermined component on a substrate,

the discharge device comprising a nozzle for discharging the liquid material in droplets, and

the droplet discharge method comprising the steps of:

cleaning the nozzle using the liquid material; and

arranging at least a part of the liquid material used for cleaning on the substrate.

7. (Original) A manufacturing method for a liquid crystal device according to claim 6,

wherein the component is an orientated film constituting a liquid crystal device or a protection film for a color filter, and

the liquid material contains a constituent material for the orientated film or the protection film.

8. (Currently Amended) A droplet discharge apparatus which ~~discharges a liquid material from a discharge device and arranges the~~disposes a liquid material in a specified quantity on a substrate, comprising:

~~wherein the discharge device has~~ a nozzle for discharging the liquid material in ~~droplets, and~~droplets;

~~the droplet discharge apparatus comprising:~~

a liquid material supply system which supplies the liquid material to the nozzle; and

a measuring device which measures a quantity of the liquid material ~~arranged~~ disposed on the ~~substrate~~substrate;

wherein a quantity of the liquid material disposed on the substrate is measured by the measuring device, and the discharge of the liquid material from the nozzle is stopped when the quantity of the liquid material disposed on the substrate reaches the specified quantity.

9. (Original) A droplet discharge apparatus according to claim 8, further comprising;

a temperature control device which warms the liquid material to room temperature or higher.

10. (Original) A liquid crystal device, comprising at least one component of a component group consisting of a liquid crystal layer, an oriented film, and a protection film for a color filter,

wherein the droplet discharge apparatus according to claim 8 is used to form at least one component of the component group.

11. (Original) An electronic apparatus comprising the liquid crystal device according to claim 10.